Sheet 1 of 4											
FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S)			ATTY DO: 2003-1	CKET NO. 770		SERIAL NEW	, NO.				
			APPLICANT Kunihiko SAKURAI et al.								
	(Use several sheets if necessary)  Date Submitted to PTO: January 5, 2004			FILING DA	ATE / 5, 2004			GROUP			
			U	<del></del>	DOCUMENTS						
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to	AA	6,062,954	5/2000		Izumi						
1_	АВ	6,156,124	12/2000		Tobin						
	AC	5,897,426	4/1999		Somekh						
	AD	6,036,582	3/2000	Aiz	zawa et al.	_					
	AE	6,180,020	1/2001	Mor	iyama et al.		زر	_			
	AF	5,655,954	8/1997	0	ishi et al.	-	7				
-	AG	5,893,795	4/1999	Pe	Perlov et al.						
	АН	5,830,045	11/1998	Togawa et al.							
AN	Al	5,738,574	4/1998	Тс	olles et al.	-		_			
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		DOCUMENT NUMBER	DATE	COUNTRY CLASS				SUBCLASS	TRANSL YES		
Do	AJ	9-232257	9/1997		JP ·			_			
	AK	97/10613	3/1997		wo			_			
	AL	5-285807	11/1993		JP			_			
<b>b</b>	АМ	197634	4/1908	G	Sermany			_			
AU	AN	96/36459	11/1996		wo						
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A	AO	U.S. Patent Application No. 09/301,718, filed April 4, 1999, entitled "Method and Apparatus For Polishing Workpiece", by Noburu SHIMIZU et al., located in Group Art Unit 3723.									
Вv	АР	Kaitoh Tei et al., "Planarization of Device Wafer with Fixed Abrasive Particles (Second Report)" Planarization Working Characteristics with Fine Silica Grindstone, from the Japan Society for Precision Engineering.									
BU	AQ U.S. Patent Application No. 09/663,417, filed September 15, 2000, entitled "Polishing Apparatus", by Kunihiko SAKURAI et al., located in Group Art Unit 3723.										
EXAMINER 1	EXAMINER Anthony Opini DATE CONSIDERED 5/11/04										

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FORM PTO 1449 (modified)  U.S. DEPARTMENT OF COMMERCE				ATTY DOCKET NO. 2003-1770						
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дъ	AA	5,679,059	10/1997	Nishi et al.	_	^				
) .	AB	4,141,180	2/1979	Gill, Jr. et al.				•		
	AG	5,827,110	10/1998	Yajima et al.						
	AD	5,232,875	8/1993	Tuttle et al.		-	J	· <del></del>		
	AE	5,649,854	7/1997	Gill, Jr.						
	AF	5,562,524	10/1996	Gill, Jr.	_	_	·			
	AG	5,329,732	7/1994	Karlsrud et al.	_	_				
4	АН	5,554,064	9/1996	Brievogel et al.						
Do	AI	5,885,138	3/1999	Okumura et al.		_				
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<b>b</b>	АМ	7-135192	5/1995	JP						
A	AN	8-64562	3/1996	JP						
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0	AO U.S. Patent Application No. 09/341,882, filed September 8, 1999, entitled "Polishing Apparatus", by Seiji KATSUOKA et al., located in Group Art Unit 3723.									
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PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S)  (Use several sheets if necessary)  Date Submitted to PTO: January 5, 2004			APPLICANT Kunihiko SAKURAI et al.						
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			. U	I.S. PATENT DOCUMENTS		•		······	
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Ao	AA	5,616,063	4/1997	Okumura et al.					-
	AB	3,906,678	9/1975	Roth		·			
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	AK	807 492 A2	11/1997	Europe		-			
	AL	10-256201	9/1998	JP			-		
4	АМ	5-74749	3/1993	JP			-		
Au	AN	2-208931	8/1990	JP					
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			FILING DATE January 5, 2004			GROUP			
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'EXAMINER INITIAL			NAME	ÇL	ASS	SUBCLASS FILING DAT APPROPRI		ATE IF RIATE	
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	AC	6,050,884	4/2000	Togawa et al.					
1	AD	6,293,855	9/2001	Yoshida et al.					
AD	AE	5,498,199	3/1996	Karlsrod et al.	,		_		
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AD	AG	4-69147	3/1997	JP	-		_		
	.AH	0 517 594	12/1992	Europe			^		
	AI	0 684 634	11/1995	Еигоре		<del>-</del> -			
	AJ	2-267950	11/1995	JP			_		
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